

*(Use several sheets if necessary)*

**NEC A32**

Application Number

**Applicant(s)**

HIGUCHI

Filing Date

**January 16, 2002**

Group Art Unit

U.S. POSTAGE






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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		9-113888	5/2/97	Japan w/abstract	G02F	1/1335		✓
		9-145918	6/6/97	Japan w/abstract	G02B	5/22		✓
		9-247584	9/19/97	Japan w/abstract	H04N	5/64		✓
		9-306366	11/28/97	Japan w/abstract	H01J	11/02		✓
		11-143371	5/28/99	Japan w/abstract	G09F	9/00		✓

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


**EXAMINER**

Thoi Van Duong

**DATE CONSIDERED**

04/17/2003

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.